

Confirmation No. 9703

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DEIXLER <i>et al.</i>	Examiner:	Pompey, Ron E.
Serial No.:	10/587,661	Group Art Unit:	2812
Filed:	October 30, 2007	Docket No.:	US030427US2 (NXPS.671PA)
Title:	METHOD OF FABRICATING A SiGe SEMICONDUCTOR STRUCTURE		

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AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Customer No.

**65913**

Dear Sir:

In acknowledgement of the non-final Office Action dated December 28, 2009,  
please reconsider the application in view of the following amendments and remarks.

A Listing of the Claims and Remarks follow.

Authorization is provided to charge **Deposit Account 50-4019 (US030427US2)**  
any fees related to this filing.